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\*\* CONTINUING DATA \*\*\*\*\* *None AICS*

\*\* FOREIGN APPLICATIONS \*\*\*\*\* *Yes AICS*  
 REPUBLIC OF KOREA 03-16434 03/17/2003

## IF REQUIRED, FOREIGN FILING LICENSE GRANTED

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Foreign Priority claimed <input checked="" type="checkbox"/> yes <input type="checkbox"/> no 35 USC 119 (a-d) conditions met <input checked="" type="checkbox"/> yes <input type="checkbox"/> no <input type="checkbox"/> Met after Allowance Verified and Acknowledged <i>AS Sh</i> Examiner's Signature <i>Amman Sarthar</i> Initials	STATE OR  COUNTRY KOREA, REPUBLIC OF	SHEETS  DRAWING 9	TOTAL  CLAIMS 20	INDEPENDENT  CLAIMS 2
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## TITLE

Method for forming a minute pattern and method for manufacturing a semiconductor device using the same

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